

<b>Notice of References Cited</b>	Application/Control No. 10/679,614		Applicant(s)/Patent Under Reexamination WATANABE, TAKESHI	
	Examiner LUCY P. CHIEN		Art Unit 2871	Page 1 of 1

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	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine translation of JP 2000-187197
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